Estimating and Testing Process Precision with Presence of Gauge Measurement Errors

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Abstract. Process capability indices have been widely used in the manufacturing industry. Those capability indices, quantifying process potential and performance, are important for any successful quality improvement activities and quality program implementation. Because of the simplicity and easy of understanding, the precision index C_p has gained its popularity for measuring process consistency. However, the quality of data on the process characteristics relies very much on the gauge measurement. Conclusions about capability of the process

just only based on the single numerical value of the index are not reliable. In this paper, we not only conduct the performance of the index C_p with gauge measurement errors, but also present adjusted confidence interval bounds and critical values for capability testing purpose of C_p with unavoidable measurement errors. Our research would help practitioners to determine whether the factory processes meet the capability requirement, and make more reliable decisions.

Key words: confidence interval, critical value, gauge measurement error, process capability analysis.

1. Introduction

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Process capability indices, which establish the relationships between the actual process performance and the manufacturing specifications, have been the focus of recent research in quality assurance and process capability analysis. Those capability indices, quantifying process potential and performance, are important for any successful quality improvement activities and quality program implementation. The first, and the original, process capability index was C_p , which was introduced outside of Japan by Juran et al. (1974), but did not gain considerable acceptance until the early 1980s. It is defined as

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$$C_p = \frac{USL - LSL}{6\sigma},$$

where LSL is the lower specification limit, USL is the upper specification limit, and σ is the process standard deviation. The numerator of C_p gives the size of the range over which the process measurements can vary, and the denominator gives the size of the range over which the process is actually varying. Obviously, it is desirable to have a C_p as large as possible. Small values of C_p would not be acceptable, since this indicates that the natural range of variation of the process does not fit within the tolerance band. Under the assumption of that process data are normal, independent, and in control, Kocherlakota (1992) developed a general guideline for the percentage NC (non-conforming units) associated with C_p, assuming that the process is perfectly centered at the midpoint of the specification range (see Table I). Mizuno (1988) presented detailed criteria for C_p, which had been widely used in U.S. industries. These criteria provide guidelines for management response to specific ranges of C_p values (see Table II).

Table I. Minimum proportion NC associated with various values of C_p

Amount of process data within specification range	C _p	Minimum % NC
6σ 8σ 10σ 12σ	1.00 1.33 1.67 2.00	$\begin{array}{c} 0.27 \times 10^{-2} \\ 0.6334 \times 10^{-4} \\ 0.5733 \times 10^{-6} \\ 0.1973 \times 10^{-8} \end{array}$

Table II. Appropriate responses to C_p values

Process capability	Assessment	Response
1.33≤C _p	Pass	Sufficient to inspect at start of operations. Can consider speeding up process or otherwise increasing
$1 \leq C_p \leq 1.33$	Needs watching	load Danger of producing defects. Needs watching
C _p < 1	Fail	Need to consider changing procedures, changing equipment and changing tolerance. Inspect total output

Moreover, Montgomery (2000) has recommended some minimum values for C_p . That is, 1.33 for existing processes, 1.50 for new processes. For product characteristics that are essential to safety, strength or performance

features, Kotz and Johnson (1993) recommend minimum values of 1.50 for existing processes and 1.67 for new processes. Because of the simplicity and easy of understanding, C_p has gained the most popularity in the manufacturing industry. Using the index C_p , the practitioners can evaluate their process precision.

However, no measurement is free from error or uncertainty even though it may be conducted with the aid of highly sophisticated measuring instruments. Montgomery and Runger (1993) pointed out that the quality of data on the process characteristics relies very much on the gauge. Any variation in the measurement process has a direct impact on the ability to make sound judgment about the manufacturing process. Conclusions about capability of the process just only based on the single numerical value of the index are not reliable. Analyzing the effects of measurement errors on process capability indices, Mittag (1997) and Levinson (1995) provided some very definitive techniques for quantifying the percentage error in process capability indices estimation in the presence of measurement errors. In this paper, we not only conduct the behavior of the widely used process capability index C_p with gauge measurement errors, but also present some statistical analysis research in order to establish reliable confidence interval bounds and critical values for estimation and testing hypothesis of C_p with unavoidable measurement errors. In Section 2, we introduce the true process capability derives from the empirical process capability. In Section 3, we discuss the expected value, the variance, and the MSE (mean square error) of the estimator of estimating C_p with gauge measurement errors. In Sections 4 and 5, because of measurement errors, we show that the confidence intervals do not maintain the stated confidence coefficient, and when we do a statistical testing, both the α -risk and the power of the test may decrease substantially. Since the power becomes slightly, a great deal of extra cost will accompany the results that quantities of qualified product units are incorrectly rejected by the customers, or renewed to the producers. To have proper confidence coefficients and to improve the power of the test with appropriate α -risk, adjusted confidence interval bounds and critical values are proposed in Section 6. Finally, we have some conclusions in Section 7.

2. Process Capability with Gauge Measurement Errors

Gauge repeatability and reproducibility (GR&R) studies focus on quantifying the measurement errors. Common approaches to GR&R studies, such as the Range method (Montgomery and Runger, 1993) and the ANO-VA method (Mandel, 1972; Montgomery and Runger, 1993) assume that the distribution of the measurement errors is normally distributed with a mean error of zero. Suppose that the measurement errors are described by a random variable M ~ Normal (0, σ_M^2), Montgomery (Montgomery and Runger, 1993) presents the gauge capability by

$$\lambda = \frac{6\sigma_{\rm M}}{\rm USL} \times 100\%.$$

For the measurement system to be deemed acceptable, the variability in the measurements due to the measurement system must be less than a predetermined percentage of the engineering tolerance. The Automotive Industry Action Group recommends some guidelines for gauge acceptance (see Table III),

Table III. Guidelines for gauge capabilities

Gauge capability	Result
$\lambda < 10\%$	Gauge system OK
$10\% < \lambda < 30\%$	May be acceptable based on importance of application,
	cost of gauge, cost of repair, and so on
$30\% < \lambda$	Gauge system needs improvement; make every effort
	to identify the problems and have them corrected

Considering the process capability in the measurement error system, we denote $X \sim Normal (\mu, \sigma^2)$ the relevant quality characteristic of a manufacturing process. Because of measurement errors, the observed variable $Y \sim Normal (\mu_Y = \mu, \sigma_Y^2 = \sigma^2 + \sigma_M^2)$ is measured by the assumption that X and M are stochastically independent, instead of measuring the true variable X. The empirical process capability index C_P^Y is obtained after substituting σ_Y for σ , and we have the relationship between the true process capability C_P as

$$C_p^{\rm Y} = \frac{C_p}{\sqrt{1 + \lambda^2 C_p^2}}.$$

Since the variation of data we observed is larger than the variation of the original data, the denominator of the index C_p becomes larger, and we will understate the true capability of the process if we calculate process capability index with variable Y. In Table IV, we list some process capabilities with $\lambda = 0.05(0.05)0.50$ for various true process capability index $C_p = 0.50, 1.00, 1.33, 1.50, 1.67, 2.00, and 2.50$. It is obviously that the gauge becomes more important as the true capability improves (Levinson, 1995). If $\lambda = 0.50$ (50%), $C_P^Y = 0.49$ with the true process capability $C_p = 0.50$, and $C_P^Y = 1.56$ with the true process capability $C_p = 2.50$. Substituting a perfect measuring instrument will help much for processes with higher capability.

	λ												
C_p	0.05	0.10	0.15	0.20	0.25	0.30	0.35	0.40	0.45	0.50			
0.50	0.50	0.50	0.50	0.50	0.50	0.49	0.49	0.49	0.49	0.49			
1.00	1.00	1.00	0.99	0.98	0.97	0.96	0.94	0.93	0.91	0.89			
1.33	1.33	1.32	1.30	1.29	1.26	1.24	1.21	1.17	1.14	1.11			
1.50	1.50	1.48	1.46	1.44	1.40	1.37	1.33	1.29	1.24	1.20			
1.67	1.66	1.65	1.62	1.58	1.54	1.49	1.44	1.39	1.34	1.28			
2.00	1.99	1.96	1.92	1.86	1.79	1.71	1.64	1.56	1.49	1.41			
2.50	2.48	2.43	2.34	2.24	2.12	2.00	1.88	1.77	1.66	1.56			

Table IV. Process capability with $\lambda = 0.05(0.05)0.50$ for various C_p

3. Expected Value, Variance, and MSE

Suppose that {X_i, i=1, 2, ..., n} denote the random sample of size n from the quality characteristics X. To estimate the precision index C_p, we consider the natural estimator \hat{C}_p defined below, where $S = [\sum_{i=1}^{n} (X_i - \bar{X})/(n-1)]^{1/2}$ is the conventional estimator of σ , which may be obtained from a stable process,

$$\hat{C}_{p} = \frac{USL - LSL}{6S}$$

On the assumption of normality, the statistic $K = (n-1)S^2/\sigma^2$ is distributed as χ^2_{n-1} , a chi-square with n-1 degrees of freedom. The PDF (probability density function) of \hat{C}_p can be expressed as (Chou and Owen, 1989)

$$f(x) = 2 \frac{(\sqrt{(n-1)/2}C_p)^{n-1}}{\Gamma[(n-1)/2]} (x)^{-n} \exp[-(n-1)C_p^2(2x^2)^{-1}].$$

By adding the well-known correction factor

$$\mathbf{b}_{n-1} = \sqrt{\frac{2}{n-1}} \Gamma\left(\frac{n-1}{2}\right) \Gamma\left(\frac{n-2}{2}\right)^{-1}$$

to \hat{C}_p , such as $\tilde{C}_p = b_{n-1}\hat{C}_P$, Pearn et al. (1992) showed that \tilde{C}_P is the UMVUE (uniformly minimum variance unbiased estimator) of C_p . The expected value and the variance of the estimator \tilde{C}_P are

$$E(\tilde{C}_p) = C_p, \quad Var(\tilde{C}_p) = \left(\frac{n-1}{n-3}b_{n-1}^2 - 1\right)C_p^2.$$

However, the sample observations are not $\{X_i, i = 1, 2, ..., n\}$ but $\{Y_i, i = 1, 2, ..., n\}$. The estimator of estimating C_p is

$$\tilde{C}_{p}^{Y} = b_{n-1} \left(\frac{USL - LSL}{6S_{Y}} \right)$$

as we use \tilde{C}_P to estimate C_p , where $S_Y = [\sum_{i=1}^n (Y_i - \bar{Y})/(n-1)]^{1/2}$. Based on the same arguments used in Chou and Owen (1989) and Pearn et al. (1992), we obtain the PDF of \tilde{C}_P^Y as

$$f(y) = 2 \frac{(\sqrt{(n-1)/2}C_p/\sqrt{1+\lambda^2 C_p^2})^{n-1}}{\Gamma[(n-1)/2]} (y)^{-n} \exp\left[\frac{-(n-1)C_p^2(2y^2)^{-1}}{1+\lambda^2 C_p^2}\right].$$

The expected value and the variance of the estimator \tilde{C}_{P}^{Y} are

$$E(\tilde{C}_{p}^{Y}) = \frac{C_{p}}{\sqrt{1 + \lambda^{2}C_{p}^{2}}}, \quad Var(\tilde{C}_{p}^{Y}) = \left(\frac{n-1}{n-3}b_{n-1}^{2} - 1\right)\frac{C_{p}^{2}}{1 + \lambda^{2}C_{p}^{2}}.$$

For $\lambda > 0$, it is obviously that \tilde{C}_p^Y is a biased estimator of C_p , and the bias is $(1/\sqrt{1 + \lambda^2 C_p^2} - 1)C_p$, which decreases in λ . Since n is a finite positive integer, $[(n-1)/(n-3)](b_{n-1})^2 - 1$ is positive, so we have $Var(\tilde{C}_p^Y) < Var(\tilde{C}_p)$. Taking into account both the bias and the variance, we consider the MSEs of the two estimators \tilde{C}_p and \tilde{C}_p^Y . By the definition of MSE (MSE = (bias)^2 + variance), the MSEs of \tilde{C}_p and \tilde{C}_p^Y , which we denote as MSE(\tilde{C}_p) and MSE(\tilde{C}_p^Y), respectively, are

$$MSE(\tilde{C}_{p}) = \left(\frac{n-1}{n-3}b_{n-1}^{2} - 1\right)C_{p}^{2}$$

MSE(
$$\tilde{C}_{p}^{Y}$$
) = $\left[\frac{n-1}{n-3}\left(\frac{b_{n-1}^{2}}{1+\lambda^{2}C_{p}^{2}}\right) - \frac{2}{\sqrt{1+\lambda^{2}C_{p}^{2}}} + 1\right]C_{p}^{2}$.

To compare MSE(\tilde{C}_p^Y) to MSE(\tilde{C}_p), we consider the function $f(C_p, n, \lambda) = MSE(\tilde{C}_p^Y)/MSE(\tilde{C}_P)$. By some reduction, we have $f(C_P, n, \lambda) = 1$ if and only if



Figure 1. (a) Surface plot of λ_0 for various n = 5 (1) 100 and $C_p = [1.00, 2.00]$ (b) plots of λ_0 versus n = 5 (1) 100 for $C_p = 1.00, 1.33, 1.50, 2.00$ (from top to bottom).

$$\lambda = \frac{2\sqrt{(n-1)b_{n-1}^2/(n-3)-1}}{2-(n-1)b_{n-1}^2/(n-3)}C_p^{-1}$$

or $\lambda = 0$. As we denote the right side of the equal sign in the above formula as λ_0 , we have $f(C_P, n, \lambda) > 1$ if $\lambda > \lambda_0$ and $f(C_P, n, \lambda) < 1$ if $\lambda < \lambda_0$ exclusive of 0. It represents that $MSE(\tilde{C}_P^Y) > MSE(\tilde{C}_P)$ if $\lambda > \lambda_0$, $MSE(\tilde{C}_P^Y) < MSE(\tilde{C}_P)$ if $\lambda < \lambda_0$ exclusive of 0, and $MSE(\tilde{C}_P^Y) = MSE(\tilde{C}_P)$ if $\lambda = \lambda_0$ or 0. Figure 1(a) shows the surface plot of λ_0 values for n = 5(1)100 and C_p in [1.00, 2.00]. Figure 1(b) plots λ_0 versus n = 5(1)100 for $C_p = 1.00$, 1.33, 1.50, 2.00. By those figures, we see that λ_0 value decreases if n or C_p increases. The maximum value of λ_0 is 1.439, which occurs at $(n, C_p) =$ (5, 1.00), and the minimum value of λ_0 is 0.072, which occurs at $(n, C_p) =$ (100, 2.00).

Figure 2(a)–(d) display the surface plots of the ratios $\gamma = f(C_P, n, \lambda)$ with n = 5(1)100 and λ in [0, 0.5] for $C_p = 1.00$, 1.33, 1.50, and 2.00. γ varies with n or λ , the variation is more noticeable in higher capability case. For large n, γ is greater than 1 for almost every value of λ , and γ increases in λ . The maximum values of γ in Figure 4(a)–(d) are 2.957, 6.110, 8.380, and 17.100, which occur at $(n, \lambda) = (100, 0.50), (100, 0.50), (100, 0.50), and (100, 0.50) respectively, and the minimum values of <math>\gamma$ in Figure 4(a)–(d) are 0.841 (1/1.189), 0.796 (1/1.256), 0.786 (1/1.272), and 0.785 (1/1.274), which occur at $(n, \lambda) = (5, 0.50), (5, 0.50), (5, 0.50), and (5, 0.39)$, respectively. The difference between MSE(\tilde{C}_P) and MSE(\tilde{C}_P) with $\gamma > 1$ is more significant than that with $\gamma < 1$.



Figure 2. (a) Surface plot of γ with n = 5(1)100 and λ in [0, 0.5] for $C_p = 1.00$, (b) surface plot of γ with n = 5(1)100 and λ in [0, 0.5] for $C_p = 1.33$, (c) surface plot of γ with n = 5(1)100 and λ in [0, 0.5] for $C_p = 1.50$, (d) surface plot of γ with n = 5(1)100 and λ in [0, 0.5] for $C_p = 2.00$.

4. Confidence Interval Bounds

Under normality assumption, the $(1 - \alpha)$ % confidence interval of C_p with confidence bounds L and U, can be established as

$$\begin{split} P\left(L \leq C_p \leq U\right) &= P\left(L \leq \frac{\tilde{C}_p}{b_{n-1}\sqrt{n-1}}K^{1/2} \leq U\right) \\ &= P\left(L^2 \left[\frac{b_{n-1}\sqrt{n-1}}{\tilde{C}_p}\right]^2 \leq K \leq U^2 \left[\frac{b_{n-1}\sqrt{n-1}}{\tilde{C}_p}\right]^2\right) = 1 - \alpha, \\ L^2 \left[\frac{b_{n-1}\sqrt{n-1}}{\tilde{C}_p}\right]^2 &= \chi^2_{n-1, 1-\alpha/2}, \qquad U^2 \left[\frac{b_{n-1}\sqrt{n-1}}{\tilde{C}_p}\right]^2 = \chi^2_{n-1, \alpha/2}, \end{split}$$

where $\chi^2_{n-1,\alpha}$ is the upper α th quantile of the χ^2_{n-1} distribution, and we can obtain the confidence bounds L and U of C_p as

$$L = \frac{\sqrt{\chi_{n-1,1-\alpha/2}^2} \tilde{C}_p}{\sqrt{n-1}b_{n-1}}, \qquad U = \frac{\sqrt{\chi_{n-1,\alpha/2}^2} \tilde{C}_p}{\sqrt{n-1}b_{n-1}}.$$

However, as a result of the measurement errors, we take \tilde{C}_P^Y as an estimator of C_p , thus the confidence bounds we calculated are

$$L^{Y} = \frac{\sqrt{\chi_{n-1,1-\alpha/2}^{2}} \tilde{C}_{p}^{Y}}{\sqrt{n-1}b_{n-1}}, \qquad U^{Y} = \frac{\sqrt{\chi_{n-1,\alpha/2}^{2}} \tilde{C}_{p}^{Y}}{\sqrt{n-1}b_{n-1}}$$

and the confidence coefficient θ (the probability that the confidence interval contains the actual C_p value) is

$$\theta = P\left(\frac{\sqrt{\chi_{n-1,1-\alpha/2}^2}\tilde{C}_p^Y}{\sqrt{n-1}b_{n-1}} \le C_p \le \frac{\sqrt{\chi_{n-1,\alpha/2}^2}\tilde{C}_p^Y}{\sqrt{n-1}b_{n-1}}\right)$$

= $P\left(\frac{\chi_{n-1,1-\alpha/2}^2(\text{USL}-\text{LSL})^2}{(n-1)36S_Y^2} \le C_p^2 \le \frac{\chi_{n-1,\alpha/2}^2(\text{USL}-\text{LSL})^2}{(n-1)36S_Y^2}\right)$
= $P\left(\frac{1}{1+\lambda^2C_p^2}\chi_{n-1,1-\alpha/2}^2 \le \chi_{n-1}^2 \le \frac{1}{1+\lambda^2C_p^2}\chi_{n-1,\alpha/2}^2\right)$

where $K^{Y} = (n-1)S_{Y}^{2}/\sigma_{Y}^{2}$ is distributed as χ_{n-1}^{2} . Figure 3(a)–(d) present plots of θ versus λ with $C_{p} = 1.00$, 1.33, 1.50, 2.00 and n = 25(25)100 (from top to bottom) for 95% confidence intervals. Obviously, those intervals do not maintain the stated confidence coefficient. The θ value decreases in measurement errors, and larger sample size or higher capability has more significant decrements. Because of the measurement errors, the confidence coefficients may become very small. For instance, when $C_{p} = 2.00$, n = 100, and $\lambda = 0.50$ (see Figure 3(d)), the confidence coefficient is only 0.26%, which is much smaller than the stated confidence coefficient 95%.

5. Capability Testing Under Measurement Errors

To determine whether a given process meets the present capability requirement and runs under the desired quality condition. We can consider the following statistical testing hypothesis, $H_0: C_p \le c$ versus $H_1: C_p > c$. Process fails to meet the capability requirement if $C_p \le c$, and meets the capability requirement if $C_p > c$. The critical value c_0 can be determined by the



Figure 3. (a) Plots of θ versus λ with $C_p = 1.00$ and n = 25(25)100 (from top to bottom) for 95% confidence intervals, (b) plots of θ versus λ with $C_p = 1.33$ and n = 25(25)100 (from top to bottom) for 95% confidence intervals, (c) plots of θ versus λ with $C_p = 1.50$ and n = 25(25)100 (from top to bottom) for 95% confidence intervals, (d) plots of θ versus λ with $C_p = 2.00$ and n = 25(25)100 (from top to bottom) for 95% confidence intervals, (d) plots of θ versus λ with $C_p = 2.00$ and n = 25(25)100 (from top to bottom) for 95% confidence intervals.

following with α -risk $\alpha(c_0) = \alpha$ (the chance of incorrectly judging an incapable process as capable),

$$P(\tilde{C}_p \ge c_0 | C_p = c) = \alpha$$

and we can obtain c_0 is

$$c_0 = \frac{b_{n-1}\sqrt{n-1}c}{\sqrt{\chi^2_{n-1,1-\alpha}}}.$$

Meanwhile, the power of the test (the chance of correctly judging a capable process as capable) can be computed as

$$\pi(C_p) = P\left(\tilde{C}_p > c_0 | C_p\right) = P\left(b_{n-1}^2 \frac{(USL - LSL)^2}{36S^2} > c_0^2 | C_p\right)$$
$$= P\left(K < \frac{b_{n-1}^2(n-1)C_p^2}{c_0^2}\right) = P\left(\chi_{n-1}^2 < \frac{C_p^2}{c^2}\chi_{n-1,1-\alpha}^2\right).$$

In the presence of measurement errors, however, the α -risk (denoted by α^{Y}) and the power of the test (denoted by π^{Y}) are

$$\begin{split} \alpha^{Y} &= P(\tilde{C}_{p}^{Y} \geq c_{0} | C_{p} = c) \\ &= P\left(\frac{b_{n-1}\sqrt{n-1}C_{p}^{Y}}{\sqrt{K^{Y}}} \geq c_{0} | C_{p} = c\right) = P\left(\frac{\sqrt{\chi_{n-1,1-\alpha}^{2}}}{\sqrt{1+\lambda^{2}C_{p}^{2}}} \geq \sqrt{K^{Y}}\right) \\ &= P\left(K^{Y} \leq \frac{1}{1+\lambda^{2}C_{p}^{2}}\chi_{n-1,1-\alpha}^{2}\right) = P\left(\chi_{n-1}^{2} \leq \frac{1}{1+\lambda^{2}C_{p}^{2}}\chi_{n-1,1-\alpha}^{2}\right) \\ \pi^{Y}(C_{p}) &= P(\tilde{C}_{p}^{Y} > c_{0} | C_{p}) \\ &= P\left(\frac{b_{n-1}\sqrt{n-1}C_{p}^{Y}}{\sqrt{K^{Y}}} > c_{0} | C_{p}\right) \\ &= P\left(\frac{C_{p}}{\sqrt{1+\lambda^{2}C_{p}^{2}}} > \frac{c}{\sqrt{\chi_{n-1,1-\alpha}^{2}}}\sqrt{K^{Y}}\right) \\ &= P\left(\frac{C_{p}^{2}\chi_{n-1,1-\alpha}^{2}}{\sqrt{c^{2}(1+\lambda^{2}C_{p}^{2})}} \times K^{Y}\right) \\ &= P\left(\chi_{n-1}^{2} < \frac{C_{p}^{2}}{c^{2}(1+\lambda^{2}C_{p}^{2})}\chi_{n-1,1-\alpha}^{2}\right). \end{split}$$

Since we underestimate the true capability of the process when we calculate process capability index using \tilde{C}_P^Y instead of \tilde{C}_P , the probability that \tilde{C}_P^Y is greater than c_0 will be less than the probability of that using \tilde{C}_P . Thus, the α -risk using \tilde{C}_P^Y to estimate C_p is less than the α -risk using \tilde{C}_P to estimate C_p is less than the α -risk using \tilde{C}_P to estimate C_p for estimate C_p is also less than the power using \tilde{C}_P to estimate C_p ($\alpha^Y \leq \alpha$), and the power using \tilde{C}_P^Y to estimate C_p ($\pi^Y \leq \pi$).

Figure 4(a)–(d) are the surface plots of α^{Y} with n = 5(1)100 and λ in [0, 0.5] for c = 1.00, 1.33, 1.50, 2.00, and $\alpha = 0.05$. Figure 5(a)–(d) are plots of π^{Y} versus λ with n = 50 and $\alpha = 0.05$ for c = 1.00, 1.33, 1.50, 2.00 and $C_{p} = c(0.20)c + 1$. Note that we have $\alpha^{Y} = \alpha$ and $\pi^{Y} = \pi$ when $\lambda = 0$ in those



Figure 4. (a) Surface plot of α^{Y} with n = 5(1)100 and λ in [0, 0.5] for c = 1.00 and $\alpha = 0.05$, (b) surface plot of α^{Y} with n = 5(1)100 and λ in [0, 0.5] for c = 1.33 and $\alpha = 0.05$, (c) surface plot of α^{Y} with n = 5(1)100 and λ in [0, 0.5] for c = 1.50 and $\alpha = 0.05$, (d) surface plot of α^{Y} with n = 5(1)100 and λ in [0, 0.5] for c = 2.00 and $\alpha = 0.05$.

figures. In Figure 4(a)–(d), α^{Y} decreases if λ or n increases, and the decrements are significant with large c values. In addition, we find that large λ values may result α^{Y} smaller than 1×10^{-4} (such as $\lambda = 0.50$, c = 2.00, and $n \ge 50$), an α -risk may be very imperceptible because of measurement errors. In Figure 5(a)–(d), π^{Y} decreases with λ , but increases with n. The decrements of power by λ are more significant with higher capability. Because of measurement errors, π^{Y} may decrease with significant decrements. For instance, we consider the π^{Y} values in Figure 5(b) (c = 1.33, n = 50) for C_p=1.93, $\pi^{Y} = 0.980$ if there is no measurement error ($\lambda = 0$), but when $\lambda = 0.50$, π^{Y} decreases to 0.104, the decrement of power is about 0.88.



Figure 5. (a) Plots of π^{Y} versus λ with n = 50 and $\alpha = 0.05$ for c = 1.00 and $C_p = 1.00(0.20)2.00$ (from bottom to top), (b) plots of π^{Y} versus λ with n = 50 and $\alpha = 0.05$ for c = 1.33 and $C_p = 1.33(0.20)2.33$ (from bottom to top), (c) plots of π^{Y} versus λ with n = 50 and $\alpha = 0.05$ for c = 1.50 and $C_p = 1.50(0.20)2.50$ (from bottom to top), (d) plots of π^{Y} versus λ with n = 50 and $\alpha = 0.05$ for c = 2.00 and $C_p = 2.00(0.20)3.00$ (from bottom to top).

6. Adjusted Confidence Bounds and Critical Values

We showed earlier that the confidence intervals do not maintain the stated confidence coefficients. We also showed that both the α -risk and the power of the test decrease when the gauge measurement error increases. If the producers do not take account of the effects of the gauge capability in process capability estimation and testing, it may result in serious loss. In that case, the producers cannot anymore affirm that their processes to be meet the capability requirement even if their processes are sufficiently capable. The producers may pay for a lot of cost because quantities of qualified product units are incorrectly rejected. Improving the gauge measurement accuracy and training the operators by proper education are essential for reducing the measurement errors. Nevertheless, measurement errors may be unavoidable in most manufacturing processes. In the following, we adjust the confidence intervals and critical values in order to ensure the intervals have the desired confidence coefficients and improve the power of the test with appropriate α -risk. Suppose that the desired confidence interval of C_p with confidence interval bounds L* and U*, can be established as

$$\begin{split} & P\left(L^* \leq C_p \leq U^*\right) = P\left(L^* \leq \frac{\tilde{C}_p^Y}{\sqrt{(n-1)b_{n-1}^2(K^Y)^{-1} - (\lambda \tilde{C}_p^Y)^2}} \leq U^*\right) \\ &= P\left(L^{*2} \left[\frac{(n-1)b_{n-1}^2(K^Y)^{-1} - (\lambda \tilde{C}_p^Y)^2}{(\tilde{C}_p^Y)^2}\right] \right] \\ &\leq l \leq U^{*2} \left[\frac{(n-1)b_{n-1}^2(K^Y)^{-1} - (\lambda \tilde{C}_p^Y)^2}{(\tilde{C}_p^Y)^2}\right] \right) \\ &= P\left(L^{*2} \left[\frac{(n-1)b_{n-1}^2(K^Y)^{-1}}{(\tilde{C}_p^Y)^2}\right] \leq 1 + L^{*2}\lambda^2\right) \\ &+ P\left(1 + U^{*2}\lambda^2 \leq U^{*2} \left[\frac{(n-1)b_{n-1}^2}{(\tilde{C}_p^Y)^2}\right] \right) \\ &= P\left(L^{*2} \left[\frac{(n-1)b_{n-1}^2}{(\tilde{C}_p^Y)^2(1 + L^{*2}\lambda^2)}\right] \leq K^Y \leq U^{*2} \left[\frac{(n-1)b_{n-1}^2}{(\tilde{C}_p^Y)^2(1 + U^{*2}\lambda^2)}\right] \right) \\ &= 1 - \alpha \\ L^{*2} \left[\frac{(n-1)b_{n-1}^2}{(\tilde{C}_p^Y)^2(1 + L^{*2}\lambda^2)}\right] = \chi_{n-1,1-\alpha/2}^2, \\ U^{*2} \left[\frac{(n-1)b_{n-1}^2}{(\tilde{C}_p^Y)^2(1 + U^{*2}\lambda^2)}\right] = \chi_{n-1,\alpha/2}^2. \end{split}$$

By some simplification, the adjusted $(1 - \alpha)$ % confidence interval bound can be written as

$$\begin{split} L^{*} &= \frac{\sqrt{\chi^{2}_{n-1,1-\alpha/2}}\tilde{C}_{p}^{Y}}{\sqrt{(n-1)b_{n-1}^{2} - (\lambda\tilde{C}_{p}^{Y})^{2}\chi_{n-1,1-\alpha/2}^{2}}},\\ U^{*} &= \frac{\sqrt{\chi^{2}_{n-1,\alpha/2}}\tilde{C}_{p}^{Y}}{\sqrt{(n-1)b_{n-1}^{2} - (\lambda\tilde{C}_{p}^{Y})^{2}\chi_{n-1,\alpha/2}^{2}}}. \end{split}$$

ESTIMATING AND TESTING PROCESS PRECISION

With our revised confidence interval bounds, we can ensure the interval would have the desired confidence coefficient. Moreover, in order to improve the power of the test, we let the critical values (denoted by c_0^*) we proposed to be satisfied $c_0^* < c_0$. Since $c_0^* < c_0$, the probability that \tilde{C}_P^Y is greater than c_0^* will be more than the probability of that \tilde{C}_P^Y is greater than c_0 . And, both the α -risk and the power increase when we take c_0^* to be critical value for testing hypothesis. Suppose that the α -risk by our revised critical values c_0^* is α^* , the revised critical c_0^* can be introduced by

$$\begin{split} &\alpha^* \!=\! P\left(\tilde{C}_p^Y \!\geq\! c_0^* | C_p \!=\! c\right) \!=\! P\left(\frac{b_{n-1}\sqrt{n-1}C_p^Y}{\sqrt{K^Y}} \!\geq\! c_0^* | C_p \!=\! c\right) \\ &=\! P\left(\frac{b_{n-1}\sqrt{n-1}C_p}{c_0^*\sqrt{1+\lambda^2}C_p^2} \!\geq\! \sqrt{K^Y} | C_p \!=\! c\right) \\ &=\! P\left(\frac{b_{n-1}^2(n-1)c^2}{c_0^{*2}(1+\lambda^2c^2)} \!\geq\! K^Y\right) \\ &=\! P\left(\chi_{n-1}^2 \!\leq\! \frac{b_{n-1}^2(n-1)c^2}{c_0^{*2}(1+\lambda^2c^2)}\right). \end{split}$$

To ensure that the α -risk is within the preset magnitude, we let $\alpha^* = \alpha$, thus c_0^* and the power (denoted by π^*) can be obtained as

$$c_{0}^{*} = \frac{b_{n-1}\sqrt{n-1}c}{\sqrt{(1+\lambda^{2}c^{2})\chi_{n-1,1-\alpha}^{2}}}$$

$$\pi^{*}(C_{P}) = P\left(\tilde{C}_{P}^{Y} > c_{0}^{*}|C_{p}\right) = P\left(\frac{b_{n-1}\sqrt{n-1}C_{p}^{Y}}{\sqrt{K^{Y}}} > c_{0}^{*}|C_{p}\right)$$

$$= P\left(\frac{C_{p}\sqrt{(1+\lambda^{2}c^{2})\chi_{n-1,1-\alpha}^{2}}}{c\sqrt{1+\lambda^{2}C_{p}^{2}}} > \sqrt{K^{Y}}\right)$$

$$= P\left(\chi_{n-1}^{2} < \left(\frac{C_{p}}{c}\right)^{2}\left(\frac{1+\lambda^{2}c^{2}}{1+\lambda^{2}C_{p}^{2}}\right)\chi_{n-1,1-\alpha}^{2}\right)$$

Figure 6(a)–(d) are plots of π^* versus λ with n = 50 and $\alpha = 0.05$ for c = 1.00, 1.33, 1.50, 2.00 and $C_p = c(0.20)c + 1$. From those figures, we see that the powers corresponding to our adjusted critical values c_0^* remain decreasing in measurement error, but the decrements originated in our adjusted critical values c_0^* is smaller than those originated in the critical values with any corrections. For instance, when we compare the π^Y values in Figure 6(b) (c = 1.33, n = 50) for $C_p = 1.93$ to the π^* values in Figure 7(b)



Figure 6. (a) Plots of π^* versus λ with n = 50 and $\alpha = 0.05$ for c = 1.00 and $C_p = 1.00(0.20)2.00$ (from bottom to top), (b) plots of π^* versus λ with n = 50 and $\alpha = 0.05$ for c = 1.33 and $C_p = 1.33(0.20)2.33$ (from bottom to top), (c) plots of π^* versus λ with n = 50 and $\alpha = 0.05$ for c = 1.50 and $C_p = 1.50(0.20)2.50$ (from bottom to top), (d) plots of π^* versus λ with n = 50 and $\alpha = 0.05$ for c = 2.00 and $C_p = 2.00(0.20)3.00$ (from bottom to top).

(c = 1.33, n = 50) for $C_p = 1.93$, we obtain that $\pi^Y = 0.104$ and $\pi^* = 0.690$ with $\lambda = 0.50$. In this case, by our adjusted critical values c_0^* , the power we improved is about 0.60. With our revised critical values, we ensure the α -risk within the preset magnitude and we have improved a certain degree of power. For our results to be practical, we provide the tables of our revised critical values for some commonly used capability requirements in Table V. Using those tables, the practitioner may skip the complex calculation and directly select the proper critical values for capability testing.

ESTIMATING AND TESTING PROCESS PRECISION

Table V. Critical values for: (a) $C_p = 1.00$, with n = 10(10)100, $\lambda = 0.05(0.05)0.50$; (b) $C_p = 1.33$, with n = 10(10)100, $\lambda = 0.05(0.05)0.50$; (c) $C_p = 1.50$, with n = 10(10)100, $\lambda = 0.05(0.05)0.50$; (d) $C_p = 2.00$, with n = 10(10)100, $\lambda = 0.05(0.05)0.50$

(a)													
	λ												
n	1-α	0.05	0.10	0.15	0.20	0.25	0.30	0.35	0.40	0.45	0.50		
10	0.950	1.502	1.496	1.487	1.474	1.459	1.440	1.419	1.396	1.371	1.345		
	0.975	1.666	1.660	1.650	1.636	1.619	1.598	1.575	1.549	1.521	1.492		
	0.990	1.895	1.888	1.876	1.861	1.841	1.817	1.791	1.762	1.730	1.697		
20	0.950	1.314	1.309	1.301	1.290	1.276	1.260	1.242	1.221	1.200	1.177		
	0.975	1.400	1.395	1.387	1.375	1.360	1.343	1.323	1.302	1.279	1.254		
	0.990	1.513	1.507	1.498	1.485	1.469	1.451	1.429	1.406	1.381	1.355		
30	0.950	1.245	1.240	1.232	1.222	1.209	1.194	1.176	1.157	1.137	1.115		
	0.975	1.308	1.303	1.295	1.284	1.270	1.254	1.236	1.216	1.194	1.171		
	0.990	1.387	1.382	1.374	1.362	1.348	1.330	1.311	1.290	1.267	1.242		
40	0.950	1.207	1.202	1.195	1.185	1.172	1.157	1.140	1.122	1.102	1.081		
	0.975	1.258	1.253	1.245	1.235	1.222	1.206	1.188	1.169	1.148	1.126		
	0.990	1.321	1.316	1.308	1.297	1.284	1.267	1.249	1.228	1.206	1.183		
50	0.950	1.182	1.177	1.170	1.160	1.148	1.133	1.117	1.099	1.079	1.058		
	0.975	1.225	1.221	1.213	1.203	1.190	1.175	1.158	1.139	1.119	1.097		
	0.990	1.280	1.275	1.267	1.256	1.243	1.227	1.209	1.190	1.168	1.146		
60	0.950	1.164	1.160	1.152	1.143	1.131	1.116	1.100	1.082	1.063	1.042		
	0.975	1.203	1.198	1.191	1.181	1.168	1.153	1.136	1.118	1.098	1.077		
	0.990	1.250	1.246	1.238	1.227	1.214	1.199	1.181	1.162	1.142	1.120		
70	0.950	1.150	1.146	1.139	1.129	1.117	1.103	1.087	1.069	1.050	1.030		
	0.975	1.185	1.181	1.174	1.164	1.151	1.137	1.120	1.102	1.082	1.062		
	0.990	1.228	1.224	1.216	1.206	1.193	1.178	1.161	1.142	1.121	1.100		
80	0.950	1.140	1.135	1.128	1.119	1.107	1.093	1.077	1.059	1.041	1.021		
	0.975	1.172	1.167	1.160	1.150	1.138	1.124	1.107	1.089	1.070	1.049		
	0.990	1.211	1.206	1.199	1.189	1.176	1.161	1.144	1.126	1.106	1.084		
90	0.950	1.131	1.127	1.120	1.110	1.098	1.085	1.069	1.051	1.033	1.013		
	0.975	1.161	1.156	1.149	1.140	1.127	1.113	1.097	1.079	1.060	1.039		
	0.990	1.197	1.192	1.185	1.175	1.163	1.148	1.131	1.113	1.093	1.072		
100	0.950	1.124	1.119	1.112	1.103	1.091	1.077	1.062	1.044	1.026	1.006		
	0.975	1.151	1.147	1.140	1.130	1.118	1.104	1.088	1.070	1.051	1.031		
	0.990	1.185	1.181	1.174	1.164	1.151	1.137	1.120	1.102	1.082	1.061		

Table V. continued

(b)

	λ													
n	1-α	0.05	0.10	0.15	0.20	0.25	0.30	0.35	0.40	0.45	0.50			
10	0.950	1.995	1.982	1.961	1.932	1.898	1.857	1.813	1.765	1.716	1.665			
	0.975	2.214	2.200	2.176	2.144	2.106	2.061	2.012	1.959	1.904	1.848			
	0.990	2.518	2.501	2.475	2.439	2.395	2.344	2.288	2.228	2.165	2.101			
20	0.950	1.746	1.734	1.716	1.691	1.660	1.625	1.586	1.545	1.501	1.457			
	0.975	1.861	1.848	1.829	1.802	1.769	1.732	1.690	1.646	1.600	1.553			
	0.990	2.010	1.997	1.975	1.947	1.911	1.871	1.826	1.778	1.728	1.677			
30	0.950	1.654	1.643	1.626	1.602	1.573	1.540	1.503	1.463	1.422	1.380			
	0.975	1.737	1.726	1.708	1.683	1.652	1.617	1.579	1.537	1.494	1.450			
	0.990	1.843	1.831	1.812	1.785	1.753	1.716	1.675	1.631	1.585	1.538			
40	0.950	1.603	1.593	1.576	1.553	1.525	1.492	1.457	1.419	1.379	1.338			
	0.975	1.671	1.660	1.642	1.618	1.589	1.555	1.518	1.478	1.437	1.394			
	0.990	1.756	1.744	1.726	1.700	1.670	1.634	1.595	1.553	1.510	1.465			
50	0.950	1.570	1.560	1.543	1.521	1.493	1.462	1.427	1.389	1.350	1.310			
	0.975	1.628	1.618	1.600	1.577	1.548	1.516	1.479	1.441	1.400	1.359			
	0.990	1.700	1.689	1.671	1.647	1.617	1.583	1.545	1.504	1.462	1.419			
60	0.950	1.547	1.536	1.520	1.498	1.471	1.440	1.405	1.368	1.330	1.291			
	0.975	1.598	1.587	1.570	1.548	1.520	1.487	1.452	1.414	1.374	1.333			
	0.990	1.661	1.650	1.633	1.609	1.580	1.546	1.509	1.470	1.429	1.386			
70	0.950	1.529	1.519	1.502	1.480	1.454	1.423	1.389	1.352	1.314	1.276			
	0.975	1.575	1.565	1.548	1.525	1.498	1.466	1.431	1.394	1.354	1.314			
	0.990	1.632	1.621	1.604	1.581	1.552	1.519	1.483	1.444	1.403	1.362			
80	0.950	1.514	1.504	1.488	1.467	1.440	1.410	1.376	1.340	1.302	1.264			
	0.975	1.557	1.547	1.530	1.508	1.481	1.449	1.415	1.378	1.339	1.299			
	0.990	1.609	1.598	1.581	1.558	1.530	1.498	1.462	1.424	1.384	1.343			
90	0.950	1.503	1.493	1.477	1.455	1.429	1.399	1.365	1.330	1.292	1.254			
	0.975	1.542	1.532	1.516	1.494	1.467	1.436	1.401	1.365	1.326	1.287			
	0.990	1.590	1.580	1.563	1.540	1.512	1.480	1.445	1.407	1.368	1.327			
100	0.950	1.493	1.483	1.467	1.446	1.420	1.390	1.356	1.321	1.284	1.246			
	0.975	1.530	1.520	1.504	1.482	1.455	1.424	1.390	1.354	1.316	1.277			
	0.990	1.575	1.565	1.548	1.525	1.498	1.466	1.431	1.393	1.354	1.314			

Table V. continued

(c)

		λ												
n	1-α	0.05	0.10	0.15	0.20	0.25	0.30	0.35	0.40	0.45	0.50			
10	0.950	2.249	2.230	2.200	2.160	2.112	2.057	1.997	1.934	1.869	1.804			
	0.975	2.496	2.475	2.442	2.397	2.343	2.282	2.216	2.146	2.074	2.002			
	0.990	2.838	2.815	2.777	2.726	2.665	2.595	2.520	2.440	2.359	2.277			
20	0.950	1.968	1.951	1.925	1.890	1.848	1.799	1.747	1.692	1.635	1.579			
	0.975	2.097	2.080	2.052	2.014	1.969	1.918	1.862	1.803	1.743	1.682			
	0.990	2.265	2.247	2.216	2.176	2.127	2.072	2.011	1.948	1.883	1.817			
30	0.950	1.864	1.849	1.824	1.791	1.750	1.705	1.655	1.603	1.549	1.496			
	0.975	1.958	1.942	1.916	1.881	1.839	1.791	1.739	1.684	1.628	1.571			
	0.990	2.078	2.060	2.033	1.996	1.951	1.900	1.845	1.787	1.727	1.667			
40	0.950	1.807	1.792	1.768	1.736	1.697	1.653	1.604	1.554	1.502	1.450			
	0.975	1.883	1.868	1.843	1.809	1.768	1.722	1.672	1.620	1.565	1.511			
	0.990	1.979	1.963	1.936	1.901	1.858	1.810	1.757	1.702	1.645	1.588			
50	0.950	1.770	1.755	1.732	1.700	1.662	1.619	1.571	1.522	1.471	1.420			
	0.975	1.835	1.820	1.796	1.763	1.723	1.678	1.630	1.578	1.525	1.472			
	0.990	1.916	1.900	1.875	1.841	1.799	1.752	1.702	1.648	1.593	1.537			
60	0.950	1.743	1.729	1.705	1.674	1.637	1.594	1.548	1.499	1.449	1.398			
	0.975	1.801	1.786	1.762	1.730	1.691	1.647	1.599	1.549	1.497	1.445			
	0.990	1.872	1.857	1.832	1.798	1.758	1.712	1.662	1.610	1.556	1.502			
70	0.950	1.723	1.709	1.686	1.655	1.618	1.576	1.530	1.482	1.432	1.382			
	0.975	1.775	1.761	1.737	1.705	1.667	1.623	1.576	1.527	1.476	1.424			
	0.990	1.839	1.824	1.800	1.767	1.727	1.682	1.633	1.582	1.529	1.476			
80	0.950	1.707	1.693	1.670	1.639	1.603	1.561	1.515	1.468	1.419	1.369			
	0.975	1.755	1.740	1.717	1.686	1.648	1.605	1.558	1.509	1.459	1.408			
	0.990	1.814	1.798	1.774	1.742	1.703	1.658	1.610	1.559	1.507	1.455			
90	0.950	1.694	1.680	1.657	1.627	1.590	1.549	1.504	1.456	1.408	1.359			
	0.975	1.738	1.724	1.701	1.670	1.632	1.590	1.543	1.495	1.445	1.395			
	0.990	1.793	1.778	1.754	1.722	1.683	1.639	1.592	1.541	1.490	1.438			
100	0.950	1.683	1.669	1.646	1.616	1.580	1.539	1.494	1.447	1.399	1.350			
	0.975	1.724	1.710	1.687	1.656	1.619	1.577	1.531	1.483	1.433	1.383			
	0.990	1.775	1.760	1.737	1.705	1.667	1.623	1.576	1.526	1.475	1.424			

Table V. continued

(d)

	λ													
n	1-α	0.05	0.10	0.15	0.20	0.25	0.30	0.35	0.40	0.45	0.50			
10	0.950	2.992	2.949	2.880	2.792	2.690	2.578	2.463	2.348	2.235	2.126			
	0.975	3.320	3.272	3.196	3.098	2.984	2.861	2.734	2.606	2.480	2.359			
	0.990	3.776	3.721	3.635	3.523	3.394	3.254	3.109	2.963	2.821	2.683			
20	0.950	2.618	2.580	2.520	2.443	2.353	2.256	2.155	2.054	1.956	1.860			
	0.975	2.790	2.750	2.686	2.603	2.508	2.404	2.297	2.190	2.084	1.983			
	0.990	3.014	2.970	2.901	2.812	2.709	2.597	2.481	2.365	2.251	2.142			
30	0.950	2.480	2.444	2.387	2.314	2.229	2.137	2.042	1.946	1.853	1.762			
	0.975	2.605	2.568	2.508	2.431	2.342	2.245	2.145	2.045	1.946	1.851			
	0.990	2.764	2.724	2.661	2.579	2.485	2.382	2.276	2.169	2.065	1.964			
40	0.950	2.404	2.369	2.314	2.243	2.161	2.072	1.979	1.887	1.796	1.709			
	0.975	2.506	2.469	2.412	2.338	2.252	2.159	2.063	1.966	1.872	1.781			
	0.990	2.633	2.595	2.534	2.457	2.367	2.269	2.168	2.066	1.967	1.871			
50	0.950	2.355	2.320	2.267	2.197	2.117	2.029	1.939	1.848	1.759	1.673			
	0.975	2.442	2.406	2.350	2.278	2.195	2.104	2.010	1.916	1.824	1.735			
	0.990	2.550	2.513	2.454	2.379	2.292	2.197	2.099	2.001	1.905	1.812			
60	0.950	2.319	2.286	2.232	2.164	2.085	1.999	1.909	1.820	1.732	1.648			
	0.975	2.396	2.361	2.307	2.236	2.154	2.065	1.973	1.880	1.790	1.703			
	0.990	2.491	2.455	2.398	2.324	2.239	2.147	2.051	1.955	1.861	1.770			
70	0.950	2.292	2.259	2.207	2.139	2.060	1.975	1.887	1.799	1.712	1.629			
	0.975	2.362	2.328	2.274	2.204	2.123	2.035	1.945	1.853	1.764	1.678			
	0.990	2.447	2.412	2.356	2.283	2.200	2.109	2.015	1.920	1.828	1.739			
80	0.950	2.271	2.238	2.186	2.119	2.041	1.957	1.870	1.782	1.696	1.614			
	0.975	2.335	2.301	2.247	2.179	2.099	2.012	1.922	1.832	1.744	1.659			
	0.990	2.413	2.378	2.323	2.251	2.169	2.079	1.986	1.893	1.802	1.715			
90	0.950	2.253	2.221	2.169	2.103	2.026	1.942	1.855	1.768	1.683	1.601			
	0.975	2.313	2.279	2.226	2.158	2.079	1.993	1.904	1.815	1.728	1.643			
	0.990	2.385	2.350	2.296	2.225	2.144	2.055	1.964	1.872	1.782	1.695			
100	0.950	2.239	2.206	2.155	2.089	2.012	1.929	1.843	1.757	1.672	1.591			
	0.975	2.294	2.261	2.208	2.141	2.062	1.977	1.889	1.800	1.714	1.630			
	0.990	2.362	2.327	2.273	2.204	2.123	2.035	1.944	1.853	1.764	1.678			

7. Conclusions

Most capability research works appeared in the literatures have not considered gauge measurement errors. Gauge capability has significant effect on process capability measurement. An inaccurate measurement system can thwart the benefits of such endeavors resulting in poor quality. Analyzing process capability without considering gauge capability leads to unreliable decisions. In this paper, we considered the performance of the precision index C_p with presence of gauge measurement errors. We investigated the accuracy of the estimator \tilde{C}_{P}^{Y} when the sample data is contaminated by random measurement errors. We showed that the confidence coefficients may become insignificant, and that the α -risk and the power of the test may decrease with a significant magnitude due to gauge measurement errors, resulting with too understating capability. It could be a serious loss to the producers if gauge capability is not considered in process capability estimation and testing. Improving the gauge measurement and properly training the operators can reduce the measurement errors. Since measurement errors may not be avoided, having proper confidence coefficients and power becomes essential. We also provided adjusted confidence bounds and critical values for practitioners to use in determining whether their processes meet the capability requirement

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